

AP20 Rec'd PCT/FTO 07 FEB 2006 Sheet 1 of 1

Form PTO-1449		U.S. Department of Commerce Patent and Trademark Office		Atty. Docket No. 2271/75845	Serial No. <b>10/367809</b> Not Yet Known		
<b>INFORMATION DISCLOSURE CITATION</b> (Use several sheets if necessary)				Applicant: Shunichi SATO et al.			
				Filing Date: Herewith	Group Art Unit:		
<b>U.S. PATENT DOCUMENTS</b>							
Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date if Appropriate
↓	/K.P./	5 6 4 9 5 5 3	7-22-1997	Pillai et al.			
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							Yes No
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<b>OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
/K.P./	Nobuhiko NISHIYAMA et al. (December 1998) "Single-Transverse Mode and Stable-Polarization Operation Under High-Speed Modulation of InGaAs-GaAs Vertical-Cavity Surface-Emitting Laser Grown on GaAs (311) B Substrate", IEEE Photonics Technology Letters, Vol. 10, No. 12, pages 1676-1678. 1998						
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<b>EXAMINER</b>		<b>DATE CONSIDERED</b>					
/Kinam Park/		04/14/2009					
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